	Application No.	Applicant(s)	
Notice of Allowability	10/673,231	BROCK ET AL.	
	Examiner	Art Unit	
	M. Alexandra Elve	1725	
The MAILING DATE of this communication appe All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RI	(OR REMAINS) CLOSED in this ap or other appropriate communication GHTS. This application is subject t	plication. If not include will be mailed in due	ed course. <b>THIS</b>
1. This communication is responsive to			
2. X The allowed claim(s) is/are <u>1-33</u> .			•
3. $\boxtimes$ The drawings filed on <u>17 February 2004</u> are accepted by the	ne Examiner.		
4.	been received.  been received in Application No cuments have been received in this  of this communication to file a reply ENT of this application.  itted. Note the attached EXAMINER as reason(s) why the oath or declara t be submitted. on's Patent Drawing Review ( PTO a Amendment / Comment or in the ( AME	national stage application complying with the recomplying and the recomplying application of the recomplying in the front (not the recomplying).	quirements IOTICE OF
Attachment(s)  1. ☑ Notice of References Cited (PTO-892)  2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948)  3. ☐ Information Disclosure Statements (PTO-1449 or PTO/SB/0)  Paper No./Mail Date  4. ☐ Examiner's Comment Regarding Requirement for Deposit  of Biological Material	5. Notice of Informal F 6. Interview Summary Paper No./Mail Da 8), 7. Examiner's Amenda 8. Examiner's Statema 9. Other	(PTO-413), te ment/Comment	,

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## **REASONS FOR ALLOWANCE**

The following is an examiner's statement of reasons for allowance: the claims as supported by the specification differs from the prior art in that it does not teach a device for processing a substrate comprising a laser source, an optical deflection and mapping system arranged in the light path of the laser beam; a glass guard shielding the optical system in the direction of the substrate, wherein the glass guard includes a heating device, adapted to heat at least a portion of the glass guard to a noticeably higher temperature than its surroundings.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to M. Alexandra Elve whose telephone number is 571-272-1173. The examiner can normally be reached on 6:30-3:00 Monday to Friday.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Tom Dunn can be reached on 571-272-1171. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

February 4, 2005.

M. ALEXANDRA ELVE PRIMARY EXAMINER

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